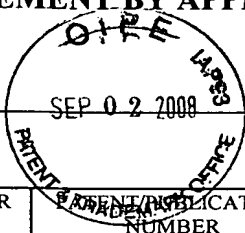


<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</b>	Docket No. <b>52433/842</b>	Application No. <b>10/576,224</b>	
	Applicant(s) <b>ISHIKAWA et al.</b>	Examiner <b>Jason L. Savage</b>	
	Filing Date <b>April 13, 2006</b>	Confirmation No. <b>9443</b>	Art Unit <b>1794</b>



## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE*

## FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	10-263817	10/06/1998	JP			Abstract	

## OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
	Chinese Office Action dated June 6, 2008 issued in corresponding Chinese Patent Application No. 2004800308784.

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	